

Formulation of a Global Model for C₈H₉Cl Plasma Coupling Gas Phase & Wall Surface Reaction Kinetics

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Topic

Formulation of a Global Model for C_8H_9Cl Plasma Coupling Gas Phase & Wall Surface Reaction Kinetics

Experiment

- Back ground
- Approach
- Result

Measurement of dominant product in C_8H_9Cl plasma

Christina

Simulation

- Approach
- Result

Calculation of rate constant for each reaction

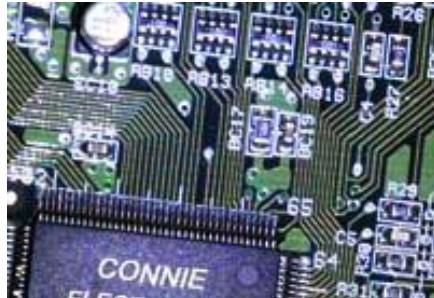
Robert
David

1. Back ground

Polymer coating Applications



Medical



Electronics

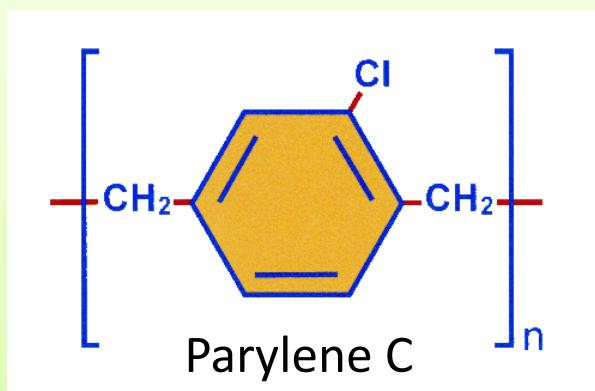


Car



Air crafts/Space Science

Parylene C is a widely used polymer



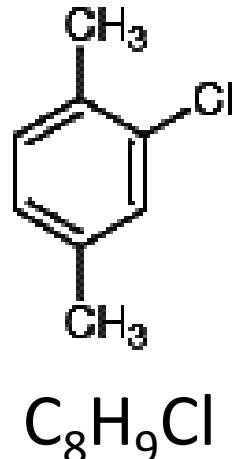
Properties

- very thin
- high water proof
- high chemical proof
- Gas imperviability
- high insulation properties
- high burning resistance

In almost all points, Parylene has better properties than the others organic coating

1. Back ground

How to make a Parylene C coating



High power

Excellent
adhesion!!

Low power

Better
functionality!!

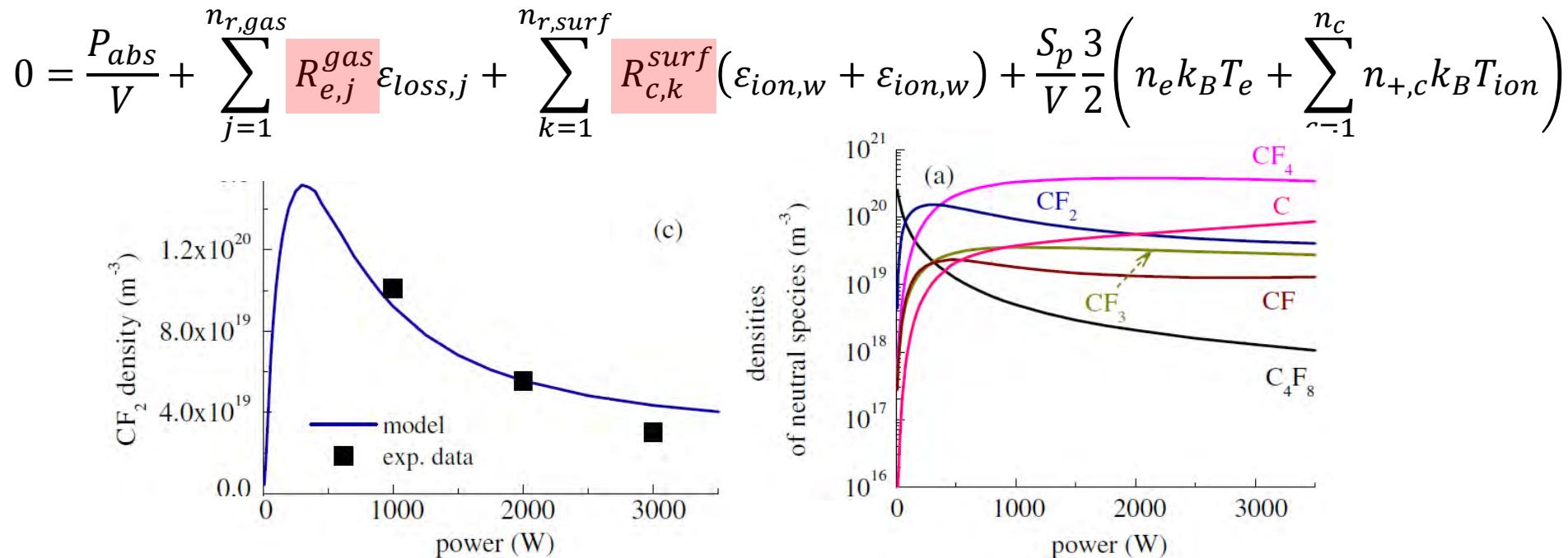
Plasma polymerization and film deposition are strongly coupled

1. Back ground

The generic mass balance at the steady state

$$0 = \frac{Q_{f,i}}{V k_B T_0} - \frac{S_p}{V} n_i + \sum_{j=1}^{n_{r,gas}} R_{i,j}^{gas} + \sum_{k=1}^{n_{r,surf}} R_{i,k}^{surf} \quad 0 = \sum_{k=1}^{n_{r,surf}} R_{m,k}^{surf}$$

The generic power balance at the steady state



production rate of species have to be known to solve this equations

2. Objective

Formulation of a Global Model for C₈H₉Cl Plasma Coupling Gas Phase & Wall Surface Reaction Kinetics

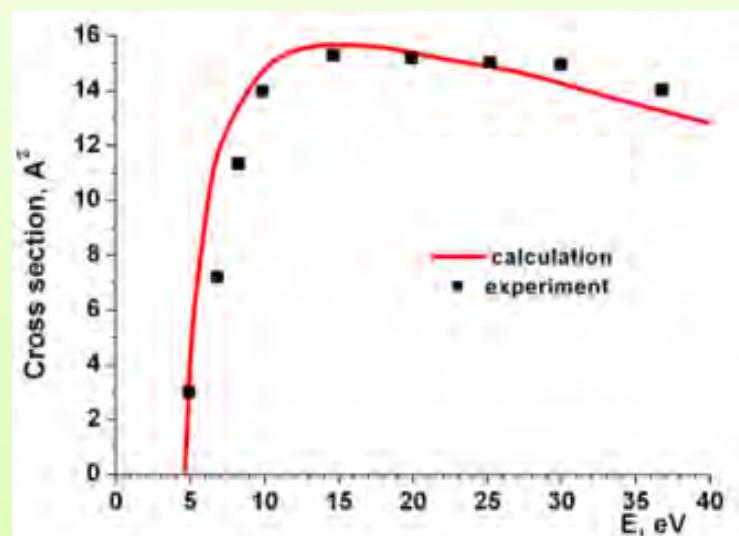
Rate constants
(for Most important chemical reactions)

$$k_v = a T_e^b \exp\left(-\frac{c}{T_e}\right) [1]$$

Calculate from Cross Sections

$$K(T_e) = \left(\frac{m}{2\pi q T_e}\right)^{\frac{3}{2}} \int_0^\infty \sigma(v) v \exp\left(-\frac{mv^2}{2qT_e}\right) dv$$

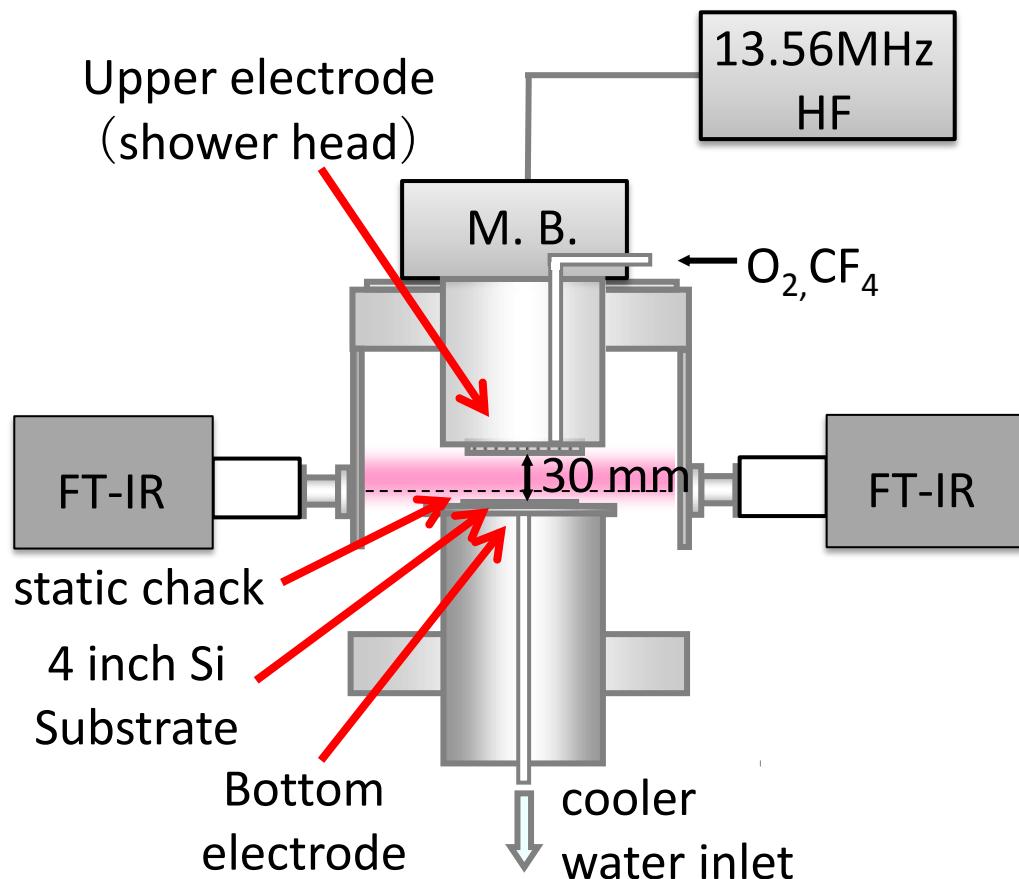
Additional data from OES e-beam



2. Equipment and condition

GEC cell^[1]

(The Gaseous Electronics Conference RF Reference Cell)



Cleaning Condition

Gas: O₂ : 30 sccm
CF₄ : 1 sccm
Upper electrode : 300 W(13.56 MHz)
Bottom electrode : 0 W
Pressure : 30 mTorr
Time : 30 min
Temperature of chamber: 60°C



Deposition Condition

Gas: ClpX(C₈H₉Cl) : 20 sccm
Upper electrode : 100 W(13.56 MHz)
Bottom electrode : 0 W
Pressure : 15 mTorr
Time : 40 min
Temperature of chamber: 60°C
Temperature of substrate: 20°C

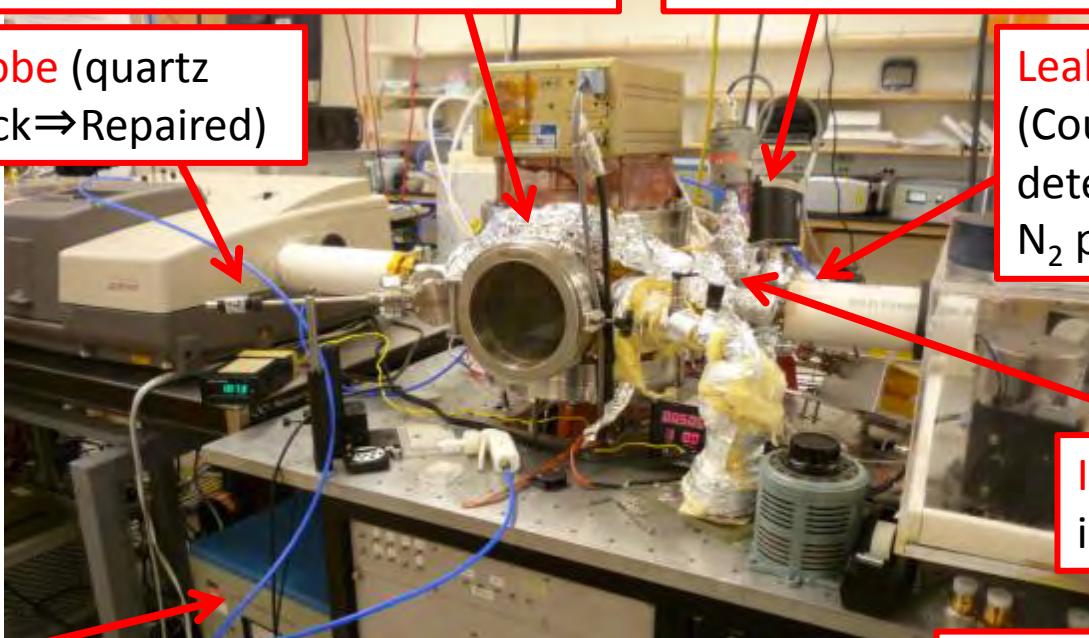
3. Fixing the GEC chamber

I Fixed the GEC(The Gaseous Electronics Conference RF Reference Cell) chamber. Most of the parts attached GEC chamber were broken. The reasons are unknown. The chamber wasn't used for half a year. Anyway, I fixed :

Ribbon heater (broken because of short ⇒ changed everything)

Barton gauge (Unavailable pressure ⇒ changed)

Floating probe (quartz tube has lack ⇒ Repaired)



Leakage of the chamber (Couldn't find with a leak detector ⇒ Found with N₂ pressurization)

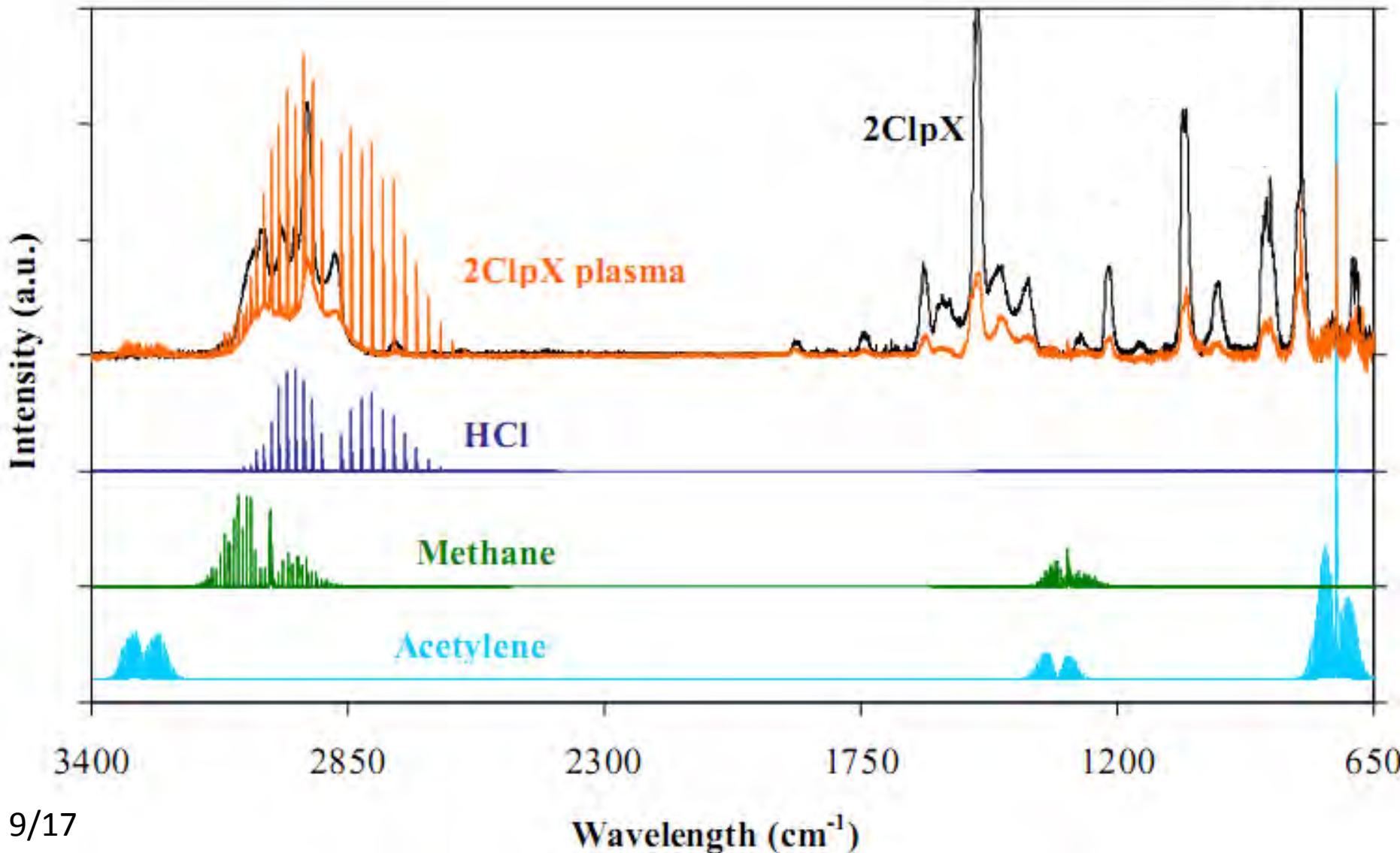
Ion gauge (Ion gauge is Broken ⇒ Changed)

Rf power supplier (Turn off unintentionally ⇒ The problem was induced with inappropriate fuse and it is changed)
8/17

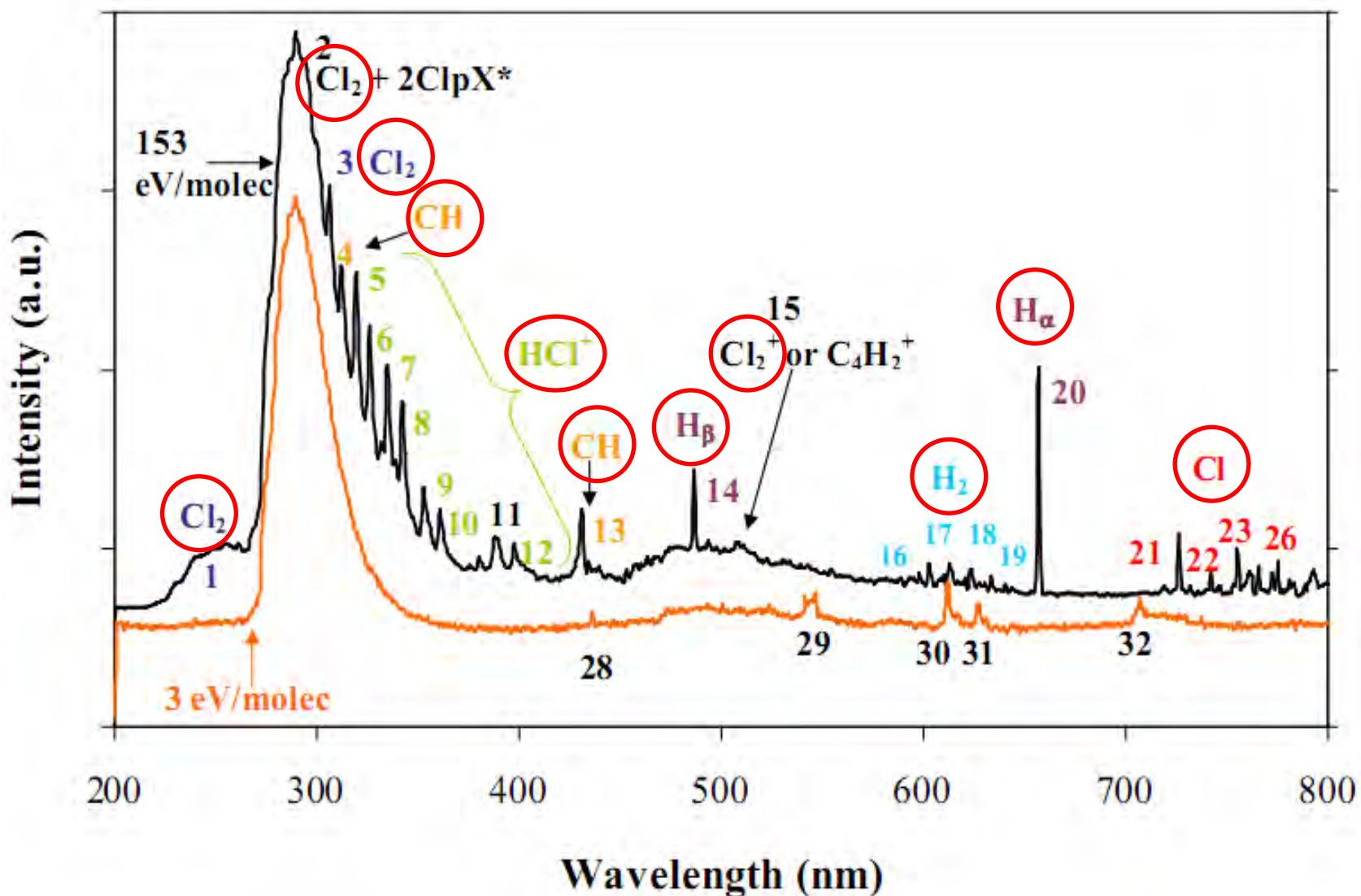
Rotary Pump (Low pumping ⇒ Solved with changing oil)

3. FT-IR spectra

Dominant product was measured with FT-IR and OES measurement.

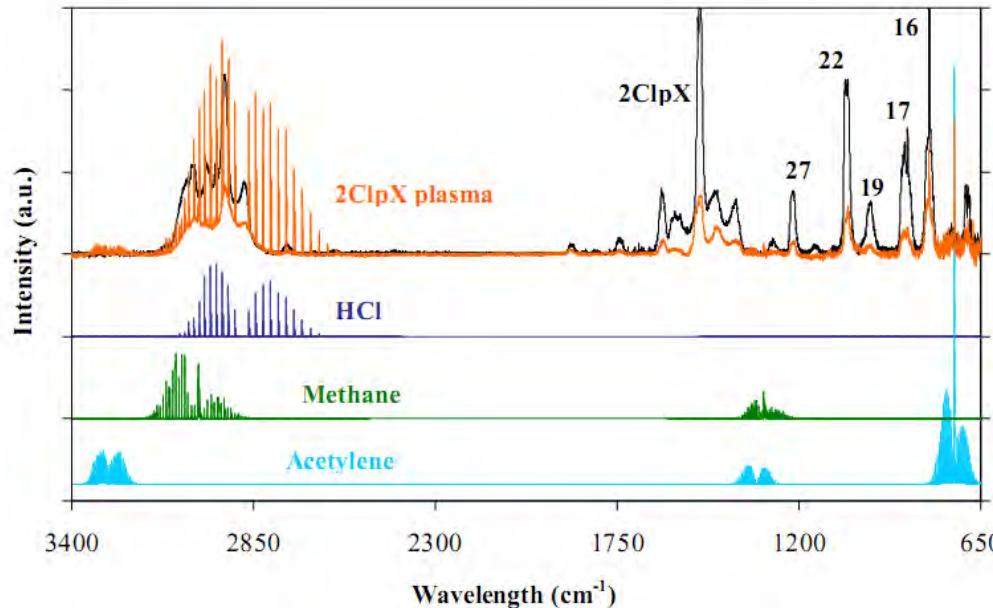


3. OES spectra



3. FT-IR and OES spectra

Dominant product was measured with FT-IR and OES measurement.

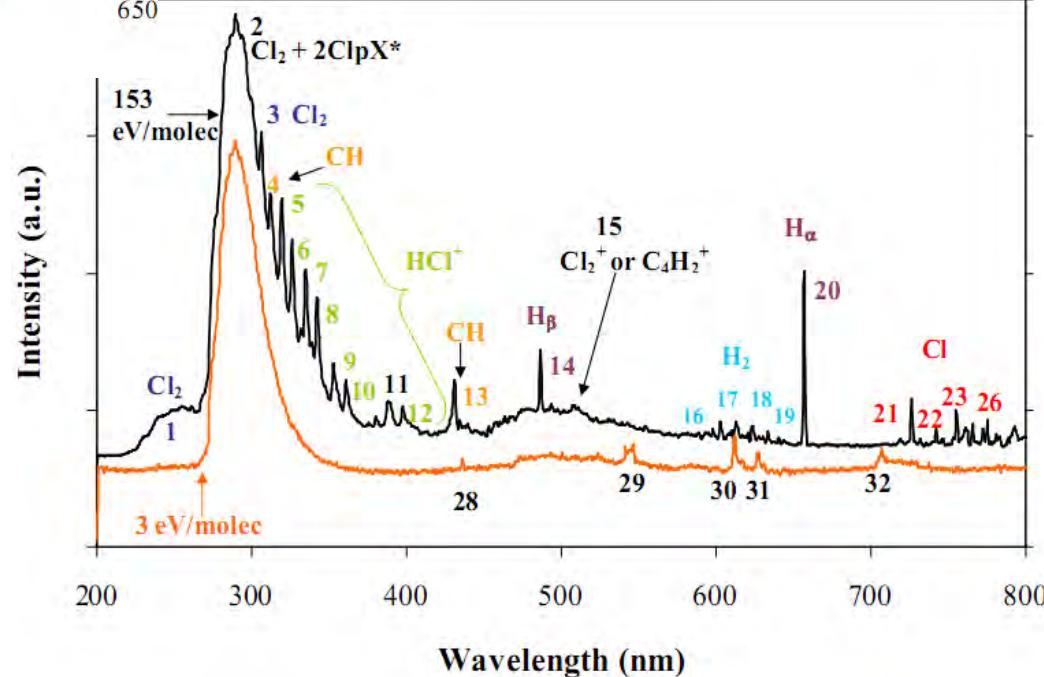


FT-IR

- ~Dissociation reaction~
- HCl
 - Methane
 - Acetylene

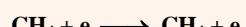
OES

- ~Excitation reaction~
- Cl_2/Cl
 - H_2/H
 - HCl
 - CH



Electron impact reactions

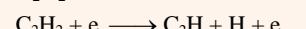
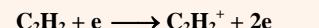
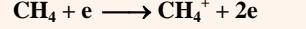
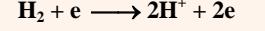
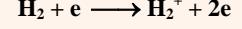
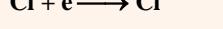
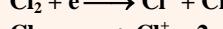
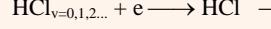
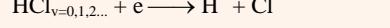
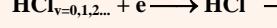
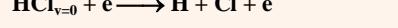
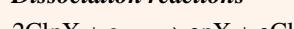
Elastic collisions



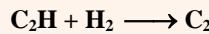
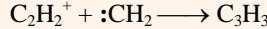
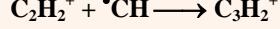
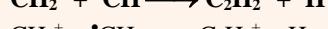
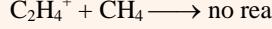
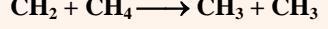
Vibrational excitation



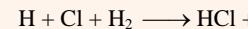
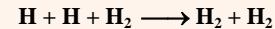
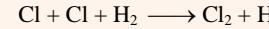
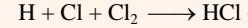
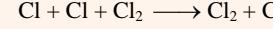
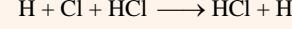
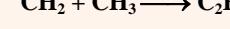
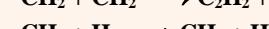
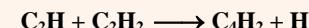
Dissociation reactions



Ion recombination reactions



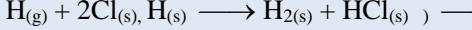
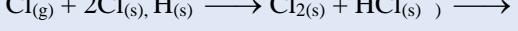
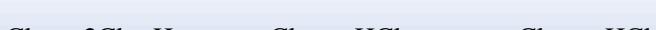
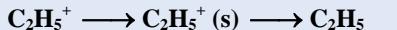
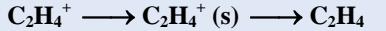
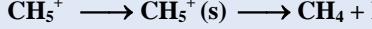
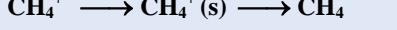
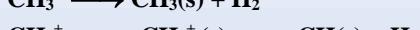
Neutral recombination reactions



Associative collisional detachment



Heterogeneous reactions



3. Approach

This Matlab code can be divided to 2 parts like shown below.

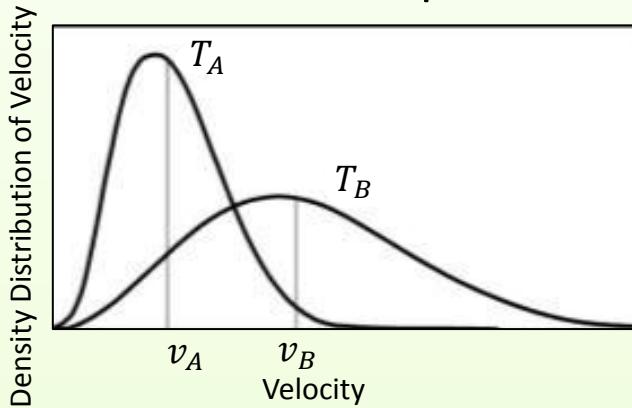
Calculation

Lberman's text book P.98 3.5

$$K(T) = \langle \sigma(v)v \rangle_V = \int \sigma(v)v \underline{f(v)} d^3v$$

$$= \int_0^\infty \sigma(v)v 4\pi v^2 \left(\frac{m}{2\pi kT}\right)^{\frac{3}{2}} \exp\left(-\frac{mv^2}{2kT}\right) dv \quad (3.5.2)$$

Maxwell Boltzman distribution equation



$$K(T) = \left(\frac{m}{2\pi kT}\right)^{\frac{3}{2}} \int_0^\infty \sigma E \exp\left(-\frac{E}{kT}\right) \frac{8mE}{m} \frac{1}{m} dv \quad (\because E = \frac{1}{2}mv^2, dE = mvdv)$$

$$K(T_e) = \left(\frac{m}{2\pi T_e q}\right)^{\frac{3}{2}} 8\pi \left(\frac{1}{m}\right)^{\frac{1}{2}} \int_0^\infty \sigma E \exp\left(-\frac{E}{T_e q}\right) dv$$

Constant

function

($\because kT = T_e q$)
 [J/K][K][eV][J/eV]

Curve Fitting

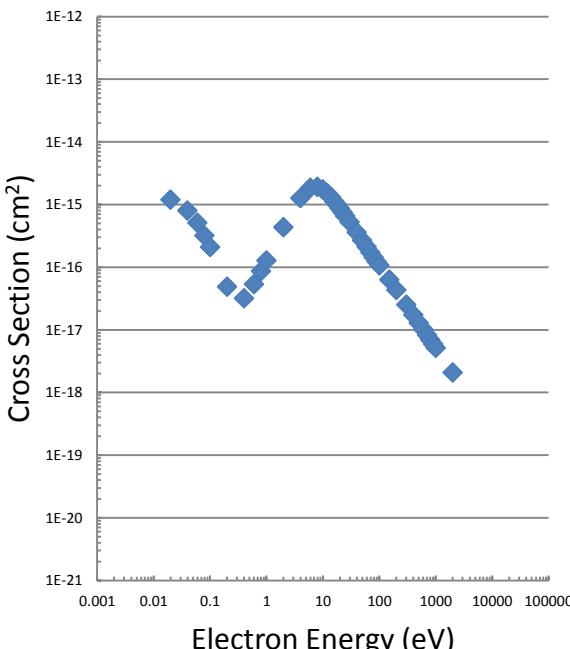
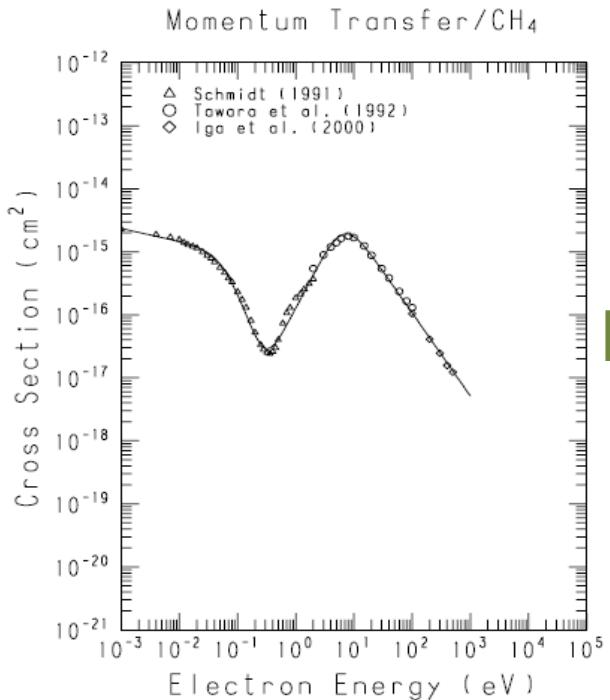
The calculated results are fitted with equation shown below.

$$K(T_e) = a T_e^b \exp\left(\frac{c}{T_e}\right)$$

(Fit-Data)/Data $\Rightarrow 0$

3. Approach

$$f(E; c_1, c_2, c_3, c_4, c_5, c_6) = \frac{\sigma_0 c_1 [(E - E_{th})/E_R]^{c_2}}{1 + [(E - E_{th})/c_3]^{c_2+c_4} + [(E - E_{th})/c_5]^{c_2+c_6}}$$



E[eV]	Cross sector [cm ²]
0.1	2.08224 × 10 ⁻¹⁶
0.2	4.82733 × 10 ⁻¹⁷
0.4	3.17070 × 10 ⁻¹⁷
0.6	5.34728 × 10 ⁻¹⁷
0.8	8.64750 × 10 ⁻¹⁷
1	1.27660 × 10 ⁻¹⁶
2	4.30073 × 10 ⁻¹⁶
4	1.26317 × 10 ⁻¹⁵
6	1.82695 × 10 ⁻¹⁵
8	1.90500 × 10 ⁻¹⁵
10	1.73384 × 10 ⁻¹⁵
12	1.50776 × 10 ⁻¹⁵
14	1.29921 × 10 ⁻¹⁵
16	1.12422 × 10 ⁻¹⁵
18	9.81177 × 10 ⁻¹⁶
20	8.64522 × 10 ⁻¹⁶
30	5.18484 × 10 ⁻¹⁶
40	3.56822 × 10 ⁻¹⁶
60	2.09677 × 10 ⁻¹⁶
80	1.43602 × 10 ⁻¹⁶
100	1.07036 × 10 ⁻¹⁶
200	4.29395 × 10 ⁻¹⁷
400	1.72230 × 10 ⁻¹⁷
600	1.00930 × 10 ⁻¹⁷
800	6.90801 × 10 ⁻¹⁸
1000	5.14785 × 10 ⁻¹⁸

Robert/David's Matlab Code

4. Results

The rate constant coefficients were shown below. $k_v = aT_e^b \exp\left(-\frac{c}{T_e}\right)$

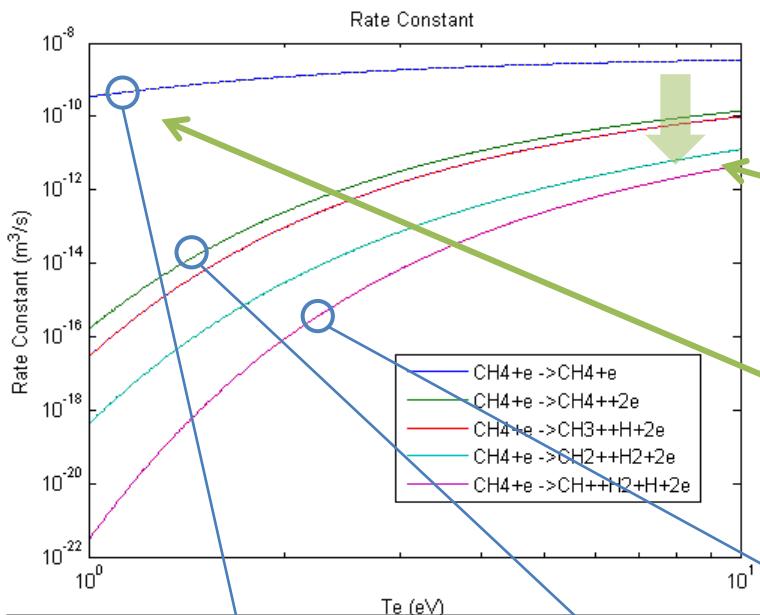
Reaction	A	B	C
$\text{CH}_4 + e \Rightarrow \text{CH}_4 + e$	4.136×10^{-13}	0.031	2.512
$\text{CH}_4 + e \Rightarrow \text{CH}_4^+ + 2e$	2.379×10^{-14}	0.388	14.255
$\text{CH}_4 + e \Rightarrow \text{CH}_3^+ + \text{H} + 2e$	1.864×10^{-14}	0.402	15.725
$\text{CH}_4 + e \Rightarrow \text{CH}_2^+ + \text{H}_2 + 2e$	4.331×10^{-16}	1.166	16.185
$\text{CH}_4 + e \Rightarrow \text{CH}^+ + \text{H}_2 + \text{H} + 2e$	9.950×10^{-16}	0.723	24.305
$\text{C}_2\text{H}_2 + e \Rightarrow \text{C}_2\text{H}_2 + e$	5.860×10^{-13}	-0.158	3.788
$\text{C}_2\text{H}_2 + e \Rightarrow \text{C}_2\text{H}_2^+ + 2e$	2.594×10^{-14}	0.618	13.583
$\text{C}_2\text{H}_2 + e \Rightarrow \text{C}_2\text{H}^+ + \text{H} + 2e$	8.387×10^{-15}	0.504	18.485
$\text{C}_2\text{H}_2 + e \Rightarrow \text{C}_2^+ + 2\text{H} + 2e$	1.301×10^{-15}	0.739	21.759
$\text{C}_2\text{H}_2 + e \Rightarrow \text{CH}^+ + \text{CH} + 2e$	1.309×10^{-15}	0.857	23.032

$\text{CF}_4 + e \Rightarrow \text{CF}_4 + e$	A	B	C
Reference	7.14×10^{-14}	0.451	0.351
From this model	6.96×10^{-14}	0.680	0.723

[1] G Kokkoris, A Goodyear, M Cooke and E Gogolides, "Global Model for C4F8 Plasma Coupling Gas Phase & Wall Surface Reaction Kinetics", J. Phys. D: Appl. Phys. **41**, 195211 (2008)

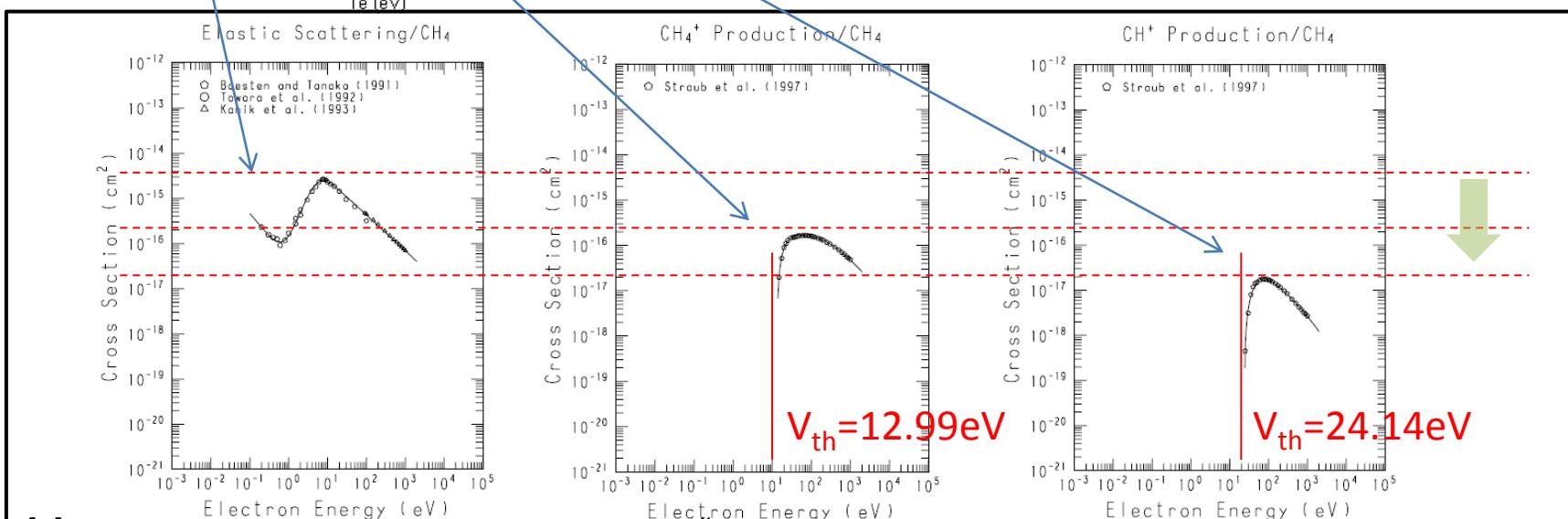
The results has good correlation with reference data.

4. Results



Rate constant magnitude affected by cross sectional data

In Elastic collision, the value doesn't decrease dramatically because the threshold energy doesn't exist



[2] T. SHIRAI, T. TABATA, H. TAWARA, Y. ITIKAWA, "ANALYTIC CROSS SECTIONS FOR ELECTRON COLLISIONS WITH

16/17 HYDROCARBONS: CH_4 , C_2H_6 , C_2H_4 , C_2H_2 , C_3H_8 , AND C_3H_6 ", Atomic Data and Nuclear Data Tables 80, (2002)

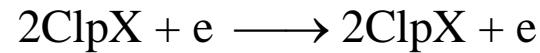
5. Conclusion

- We established rate coefficient calculation system from cross sectional data.
- More results are needed for the simulation Global Model for C₈H₉Cl Plasma Coupling Gas Phase & Wall Surface Reaction Kinetics.

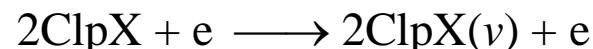
6. Future work

- The others rate constant will be calculated with the cross sectional data from the papers obtained already.
- Cross sectional data will be measured with OES e-beam equipment to get constant rates for all reactions.

Elastic collisions



Vibrational excitation



Dissociation reactions

